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AMENDMENT TRANSMITTAL LETTER				Docket No. 0649-0901P	
Application No. 10/620,461-Conf. #9184		Filing Date July 17, 2003		Examiner T. J. Magee	
Art Unit 2811					
Applicant(s): Takeshi MISAWA					
Invention: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME					
MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	16	- 20 =	0	x	
Independent Claims	3	- 3 =	0	x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>02-2448</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
Michael R. Cammarata Attorney Reg. No.: 39,491				Dated: <u>July 21, 2005</u>	
BIRCH, STEWART, KOLASCH & BIRCH, LLP 8110 Gatehouse Rd Suite 100 East P.O. Box 747 Falls Church, Virginia 22040-0747 (703) 205-8000					



Docket No.: 0649-0901P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takeshi MISAWA

Application No.: 10/620,461

Confirmation No.: 9184

Filed: July 17, 2003

Art Unit: 2811

For: SEMICONDUCTOR DEVICE AND METHOD
FOR MANUFACTURING THE SAME

Examiner: T. J. Magee

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 21, 2005

Sir:

In response to the Office Action dated April 27, 2005, please amend the above-identified
U.S. patent application as follows:

Amended Claim Set; and

Remarks.